

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Koji SHIGEMURA, et al.

Application No.:

Group Art Unit:

Filed: November 24, 2003

Examiner:

For: EVAPORATION MASK, METHOD OF FABRICATING ORGANIC
ELECTROLUMINESCENT DEVICE USING THE SAME, AND ORGANIC
ELECTROLUMINESCENT DEVICE

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure provisions of 37 CFR § 1.56, there is hereby provided certain information which the Examiner may consider material to the examination of the subject U.S. patent application. It is requested that the Examiner make this information of record if it is deemed material to the examination of the subject application.

1. Enclosures accompanying this Information Disclosure Statement are:
 - 1a. Form PTO-1449.
 - 1b. Copies of IDS citations.
 - 1c. An English language copy of search report(s) from a counterpart foreign application or a PCT International Search Report.
 - 1d. English language translation (complete or relevant portion(s)) attached to each non-English language publication.
 - 1e. Explanations of Relevancy of References (ATTACHMENT 1(e), hereto) for providing a concise explanation of each non-English publication.
2. In accordance with 37 CFR § 1.98, a concise explanation of what is presently understood to be the relevance of each non-English language publication is
(Check appropriate Items 2a, 2b, 2c and/or 2d)
 - 2a. satisfied because all non-English language publications were cited on the enclosed "English-language version of the search report or action which indicates the degree of relevance found by the foreign office". (See MPEP 609, Minimum Requirements for an Information Disclosure Statement, Part A(3): Concise Explanation of Relevance, pp. 600-100 to 600-101, Rev. 1, Feb. 2000.)
 - 2b. set forth in the application.

2c. satisfied because an English language translation (complete or relevant portion(s)) is attached to each non-English language publication.

2d. enclosed as Attachment 1(e), hereto.

3. No admission is made that the information cited in this Statement is, or is considered to be, material to patentability nor a representation that a search has been made (other than search report(s) from a counterpart foreign application or a PCT International Search Report, if submitted herewith). 37 CFR §§ 1.97(g) and (h).

Respectfully submitted,

STAAS & HALSEY LLP

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FORM PTO-1449

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICEATTORNEY DOCKET NO.
1670.1019

APPLICATION NO.

LIST OF REFERENCES CITED BY APPLICANT

(Use several sheets if necessary)

FIRST NAMED INVENTOR

Koji SHIGEMURA, et al.

FILING DATE

GROUP ART UNIT

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NO.	DATE	NAME	CLASS	SUB-CLASS	FILING DATE
	AA						
	AB						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUB-CLASS	TRANSLATION YES NO
	AC	2001-247961	9-14-01	Japanese			X
	AC	2001-273979	10-5-01	Japanese			X
	AE	2001-254169	9-18-01	Japanese			X
	AF	2002-9098	1-11-02	Japanese			X
	AG	2002-8859	1-11-02	Japanese			X
	AH	2000-48954	2-18-00	Japanese			X
	AI	2000-173769	6-23-00	Japanese			X
	AJ	2001-203079	7-27-01	Japanese			X
	AK	2001-110567	4-20-01	Japanese			X

OTHER REFERENCES (INCLUDING AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.)

AM	
AN	
AO	

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

ATTACHMENT 1(e)

EXPLANATIONS OF RELEVANCY OF REFERENCES	ATTORNEY DOCKET NO.	APPLICATION NO.
	1670.1019	
	FIRST NAMED INVENTOR	
	Koji SHIGEMURA, et al.	
	FILING DATE	GROUP ART UNIT

Reference AC: Japanese Publication No. 2001-247961, published 9-14-01, is generally related to "EVAPORATION MASK, METHOD OF FABRICATING ELECTROLUMINESCENT DEVICE USING THE SAME, AND ORGANIC ELECTROLUMINESCENT DEVICE"

Reference AD: Japanese Publication No. 2001-273979, published 10-5-01, is generally related to "EVAPORATION MASK, METHOD OF FABRICATING ELECTROLUMINESCENT DEVICE USING THE SAME, AND ORGANIC ELECTROLUMINESCENT DEVICE"

Reference AE: Japanese Publication No. 2001-254169, published 9-18-01, is generally related to "EVAPORATION MASK, METHOD OF FABRICATING ELECTROLUMINESCENT DEVICE USING THE SAME, AND ORGANIC ELECTROLUMINESCENT DEVICE"

Reference AF: Japanese Publication No. 2002-9098, published 1-11-02, is generally related to "EVAPORATION MASK, METHOD OF FABRICATING ELECTROLUMINESCENT DEVICE USING THE SAME, AND ORGANIC ELECTROLUMINESCENT DEVICE"

Reference AG: Japanese Publication No. 2002-8859, published 1-11-02, is generally related to "EVAPORATION MASK, METHOD OF FABRICATING ELECTROLUMINESCENT DEVICE USING THE SAME, AND ORGANIC ELECTROLUMINESCENT DEVICE"

Reference AH: Japanese Publication No. 2000-48954, published 2-18-00, is generally related to "EVAPORATION MASK, METHOD OF FABRICATING ELECTROLUMINESCENT DEVICE USING THE SAME, AND ORGANIC ELECTROLUMINESCENT DEVICE"

Reference AJ: Japanese Publication No. 2001-203079, published 7-27-01, is generally related to "EVAPORATION MASK, METHOD OF FABRICATING ELECTROLUMINESCENT DEVICE USING THE SAME, AND ORGANIC ELECTROLUMINESCENT DEVICE"

Reference AK: Japanese Publication No. 2001-110567, published 4-20-01, is generally related to "EVAPORATION MASK, METHOD OF FABRICATING ELECTROLUMINESCENT DEVICE USING THE SAME, AND ORGANIC ELECTROLUMINESCENT DEVICE"